Application No. 10/734,704 mendment Dated July 24, 2006 By to Final Office Action of May 23, 2006

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re the application of

Examiner: Edwards, Laura Estelle

REDEKER et al.

Art Unit: 1734

Application No.: 10/734,704

Docket No.: LAM2P461

Filed: December 12, 2003

Date: July 24, 2006

METHOD AND APPARATUS FOR

SEMICONDUCTOR WAFER

PLANARIZATION

**CERTIFICATE OF MAILING** 

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 24, 2006.

Kenneth D. Wright

## REQUEST FOR RECONSIDERATION

Mail Stop: AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This Request for Reconsideration is submitted in response to the Final Office Action dated May 23, 2006, and within the two month period extending from the date of the Final Office Action to July 24, 2006. Please note that July 23, 2006, is a Sunday. Therefore, the two month after-final period extends to Monday, July 24, 2006. Please enter the following remarks.

The Claims are reflected in the listing of claims which begins on page 2 of this Request for Reconsideration.

Remarks/Arguments begin on page 7 of this Request for Reconsideration.